

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. <b>283425US0PCT</b>		SERIAL NO. <b>10/562,121</b>	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT <b>Carole BAUBET, et al.</b>			
				FILING DATE <b>June 28, 2006</b>		GROUP <b>1794</b>	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
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	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES                      NO		
	AO						
	AP						
	AQ						
	AR						
	AS						
	AT						
	AU						
	AV						
<b>OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
	AW	Influence of Ar ion-beam assistance and annealing temperatures on properties of TiO <sub>2</sub> thin films deposited by reactive DC magnetron sputtering, Sung-Hwa Kim, et al., Elsevier, pp. 155-159, Thin Solid Films 475 (2005).					
	AX	DC reactive magnetron sputtering with Ar ion-beam assistance for titanium oxide films, S.-H. Kim, et al., Elsevier, pp. 457-464, Surface and Coatings Technology 158-159 (2002).					
	AY	The effect of the ion beam energy on the properties of indium tin oxide thin films prepared by ion beam assisted deposition, Li-Jian Meng, et al., Elsevier, pp. 1365-1369, Thin Solid Films 516 (2008).					
	AZ	Structure and properties of TiO <sub>2</sub> films prepared by ion beam assisted deposition, Xiaoling Cheng, et al., Elsevier, pp. 5552-5555, Surface Coatings & Technology 201 (2007).				<input type="checkbox"/> Additional References sheet(s) attached	
Examiner		/Lauren Robinson/					
		Date Considered				03/24/2010	
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /L.R./